

PATENT APPLICATION

**RESPONSE UNDER 37 CFR §1.116
EXPEDITED PROCEDURE
TECHNOLOGY CENTER ART UNIT 2891**

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re the Application of

Hideharu ITATANI et al.

Group Art Unit: 2891

Application No.: 10/521,248

Examiner: C. EVERHART

Filed: April 11, 2005

Docket No.: 122430

For: METHOD OF MANUFACTURING SEMICONDUCTOR DEVICE AND SUBSTRATE
PROCESSING APPARATUS

AMENDMENT AFTER FINAL REJECTION UNDER 37 CFR §1.116

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Sir:

In reply to the March 24, 2008 and April 1, 2008 Office Actions, please consider the
following:

Amendments to the Claims as reflected in the listing of claims; and

Remarks.